

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application No. : 10/743,105
Applicant : Christoph Nolscher
Confirmation No. : 8012
Filed : December 23, 2003
TC/A.U. : 1756
Examiner : Chacko Davis, Daborah
Customer No. : 27896
Docket No. : 3000.0016C
Title : Method for Forming a Structure Element on a Wafer by Means of a Mask and Trimming Mask Assigned Hereto

ISSUE FEE TRANSMITTAL

IN RESPONSE TO THE NOTICE OF ALLOWANCE MAILED JULY 17, 2007, ENCLOSED ARE

Issue Fee Transmittal (Form PTOL 85b)
 Other: _____

THE FEES HAVE BEEN CALCULATED AS FOLLOWS:

Issue Fee: \$1440.00 Publication Fee (\$300): \$300.00
(S1440 Large Entity/S720 Small Entity)
 Other Fees: \$_____

Total Fee Due: \$1740.00

Credit card payment has been submitted concurrently with the filing of this transmittal. The Director is hereby authorized to charge any additional appropriate fees that may be required during the pendency of the above-identified application (e.g., in the concurrent or in any future reply), as well as to credit any overpayment, to Deposit Account No. **05-0460**.

Dated: October 10, 2007

Respectfully submitted by:

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